



Docket No.: 008066 USA/MTCG/PCTRL/JW

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Susie Xiuru YANG et al. :
Serial No. 10/809,908 : Group Art Unit: 2812
Filed: March 26, 2004 : Examiner:
:

For: IMPROVED CONTROL OF METAL RESISTANCE IN SEMICONDUCTOR
PRODUCTS VIA INTEGRATED METROLOGY

PETITION FOR EXTENSION OF TIME

Honorable Commissioner for Patents
Alexandria, VA 22313-1450

Sir:

Applicant petitions the Commissioner for Patents to extend the time for response to the Notice to File Corrected Application Papers dated June 7, 2004 for one month, from August 7, 2004 to September 7, 2004.

Please charge the \$110.00 fee to cover the cost of the extension to Deposit Account No. 08-0219. Any deficiency or overpayment should be charged or credited to Deposit Account No. 08-0219.

Respectfully submitted,

Wilmer Cutler Pickering Hale and Dorr LLP



Scott M. Alter
Registration No. 32,879

08/30/2004 SZEWDIE1 00000153 080219 10809908

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The Willard Office Building
1455 Pennsylvania Avenue, NW
Washington, DC 20004
202 942 8400
Date: 9/27/04